

Notice of References Cited	Application/Control No. 10/595,234		Applicant(s)/Patent Under Reexamination AKAI ET AL.	
	Examiner Tina M. Wong		Art Unit 2874	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,774,968	08-2004	Hagiwara, Takeshi	349/139
*	B	US-6,768,533	07-2004	Hanakawa et al.	349/153
*	C	US-6,844,911	01-2005	Lee, Jong-Chil	349/190
*	D	US-7,215,405	05-2007	Kim et al.	349/187
*	E	US-2003/0107699	06-2003	Jung et al.	349/153
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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